

Electronic Control and Readout of Qubit States in Solid State Quantum Computing Systems

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Abstract

We demonstrate that an n^+i junction is the most suitable candidate for electronic control and readout of qubit states in quantum computing systems based on shallow impurities. The signature of this system is that the n^+ regions serve as metallic electrodes separated from the i region by a self-induced barrier (internal workfunction). The n^+i system mimics the properties of a metal-vacuum-metal junction with the qubit (impurity atom) placed in a vacuum i -region between two "metallic" n^+ electrodes. We will show that the self-induced barrier exists in a sufficiently wide range of the concentration of dopants in the n^+ -semiconductor (e.g. up to 10^{21} cm⁻³ for Si) and its height can be controlled by tuning the doping level. A shallow donor placed in a vacuum i -region will be populated with one electron in equilibrium. In the case of Li donor in Si the n^+ -electrodes will be used for a precision placement of the Li atom during the growth process; for voltage control and manipulation of the qubit states; and for a qubit readout by means of the optically stimulated resonant tunnelling. Another important feature of our system is that the qubit states (first two lowest energy levels of Li in Si) are separated by an energy gap from a continuum of the many-body states of the controlling electrodes.

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Introduction. Various systems have been proposed during last decade as potential candidates for solid state quantum computing (QC). All these systems are based on control of either localized spins or localized charged states in semiconductors. In particular, it was proposed to encode qubits on: nuclear spins of ^{31}P donors [1, 2] or ^{29}Si isotopes [3] in Si matrix; spins of electrons localized in semiconductor quantum dots (QDs) [4, 5, 6, 7, 8, 9, 10]; and on charged states of shallow impurities in Si [11, 12]. For all these cases the distance d between neighboring qubits ranges from $\sim 5\text{nm}$ [1, 2, 3] to 100nm [11, 12] and electronic control must be used for a readout and for one- and two-qubit gates. It is clear, that the distance a between an individual qubit and its controlling electrode has to be smaller than the interqubit separation d to ensure a proper space resolution of the qubits. Thus the distance a must be in the range $a \lesssim 5\text{nm}$ (nuclear spins [1, 2, 3]) and $a \lesssim 20\text{nm}$ (shallow impurities in Si [11, 12]).

It seems almost obvious that one can use metal electrodes for control and readout of the solid state qubits. As it has been suggested in most of the solid state QC proposals [1, 2]–[11], the thin metal electrodes have to be deposited directly on a Si surface or on a thin insulating SiO_2 layer grown on this surface. A careful analysis of this idea reveals that a single shallow donor in an undoped semiconductor placed in a proximity ($a \sim 5\text{--}20\text{nm}$) of an interface with the metal will be ionized. It simply means that the qubit cannot be formed. This conclusion is in agreement with the fact the localized electrons on shallow impurities placed in vicinity of metal electrodes have not been observed in QC experiments. Indeed, it is well known that a high potential barrier (a Schottky barrier) is always formed at metal–semiconductor (MS) or metal–insulator–semiconductor (MIS) interfaces [13]. The barrier height is determined by a large density of the interfacial states that pin the Fermi level E_F at energy $\sim 0.5\text{--}0.8\text{ eV}$ below the conduction band edge $E_c(0)$ at the interface. The pinning occurs for Si and GaAs in contacts with almost all metals and for doping concentrations $N \sim 10^{16}\text{ cm}^{-3}$ the barrier width l_d is in the range $l_d \sim 100\text{ nm}$ [13]. However an extremely pure (i-)S layer with defect density $N \sim 10^{10}\text{ cm}^{-3}$ has to be used for the solid state QC. For these concentrations the barrier width l_d is in the range of μm or more, and inside i-S layer the conduction band edge $E_c(z)$ is practically constant at the distances to the interface corresponding to the qubit location, $z \sim a \sim 20\text{ nm}$. Therefore the potential of the i-S layer between two control metal electrodes will be flat (see Fig.1(a)). The barrier height is in the range $0.5\text{--}0.8\text{ eV}$ and all shallow donors with ionization energy $I_d \lesssim 100\text{ meV}$ will be

ionized.

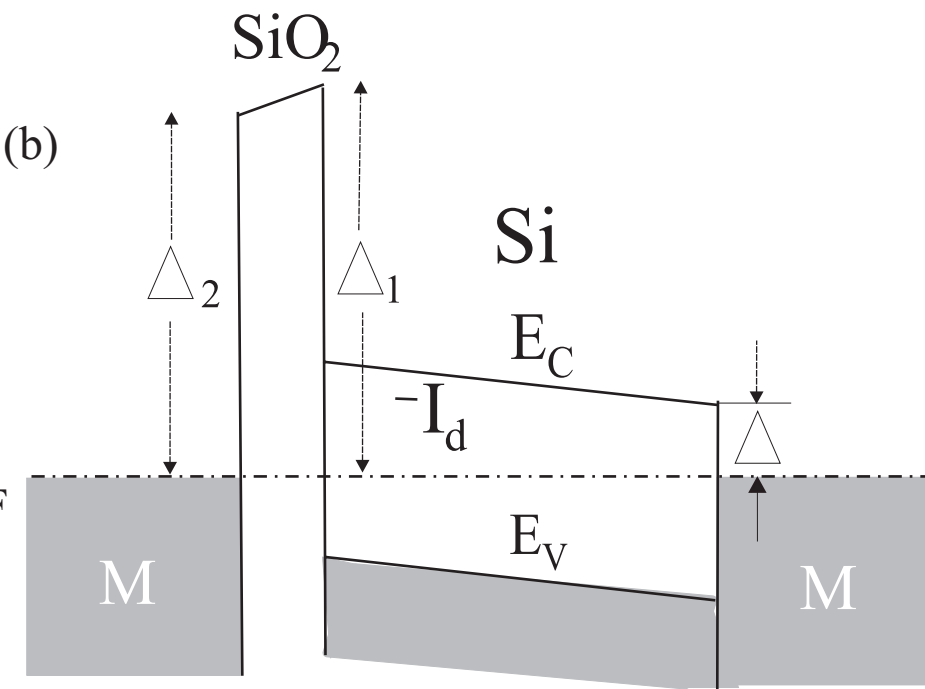
One can apply an electric field to push the impurity level below the Fermi energy of the left electrode (see Fig. 1 (a)). However the required electric field, $E' = ae \approx 3 \times 10^6 \text{ V/cm}$ (e is the elementary charge), is so strong that the impurity will be ionized due to the Zener tunnelling breakdown into the right contact [13].

The potential barrier can be efficiently decreased if a very thin heavily doped n^+ -Si layer with donor concentration $N_d^+ \approx 10^{20} \text{ cm}^{-3}$ is formed between M and i-Si layers [13]. The required conditions will be fulfilled if $E_F < E_c(a) < E_F + I_d$ in i-semiconductor layer at a distance a (cf. Fig. 1 (a)). Unfortunately, these extremely stringent conditions cannot be satisfied simultaneously for a sufficiently large interface plane and a sequence of donor qubits located near it, because of the large fluctuations of the Schottky barrier and the number of donors N_d^+ in the thin n^+ layer [14, 15, 16, 17]. Similar overwhelming obstacles also arise in MIS structures with thin insulating layers (Fig. 1 (b)). We note that the barrier height ϕ_1 at SiO_2 -Si interface is about 4 eV [13] and therefore it is impossible to push the donor level below E_F with any realistic electric fields.

The purpose of this paper is to demonstrate that an $n^+ = i = n^+$ junction is the most suitable candidate for electronic control and readout of qubit states in quantum computing systems based on shallow impurities. The signature of this system is that the n^+ regions serve as metallic electrodes separated from the i region by a self-induced barrier (internal work-function). The $n^+ = i = n^+$ system mimics the properties of a metal-vacuum-metal junction with the qubit (impurity atom) placed in a "vacuum" i -region between two "metallic" n^+ electrodes. As we will see below, the self-induced barrier exists in a sufficiently wide range of the concentration of dopants in the n^+ -semiconductor (e.g. up to 10^{20} cm^{-3} for Si) and its height can be controlled by tuning the doping level. A shallow donor placed in a vacuum i -region will have its ground state energy below the Fermi level and will be populated with one electron in equilibrium.

Finally, we note that for a qubit based on Li donor in Si [12] the same n^+ -electrodes can be used for a precision placement of the electro-migrating Li ions during the growth process; for voltage control and manipulation of the qubit states in Li at low temperatures; and for a qubit readout by means of the optically stimulated resonant tunnelling.

1. LDA treatment of doped semiconductor $n^+ - i$ structure. Let us consider formation



of a barrier Φ_s at a $n^+ = i$ interface. We will assume that the donor concentration in n^+ region exceeds the threshold of the metal-insulator phase transition. If we replace spatial distribution of ionized donors with positive uniform charge and consider a single-valley parabolic-band n -type semiconductor (e.g. GaAs) the problem can be mapped onto the problem of a metal-vacuum interface [18, 19, 20]. The barrier of an $n^+ = i$ junction or, equivalently, the workfunction of a simple metal can be expressed in the form known as Budd-Vannin enus theorem [21, 22]:

$$\Phi_s = (1) - (0) - \epsilon: \quad (1)$$

The meaning of Eq. (1) is illustrated in Fig. 2 where a schematic band diagram of the $n^+ = i$ -junction is shown. The energies E_C^+ and E_C^i are the conduction band edges of n^+ and

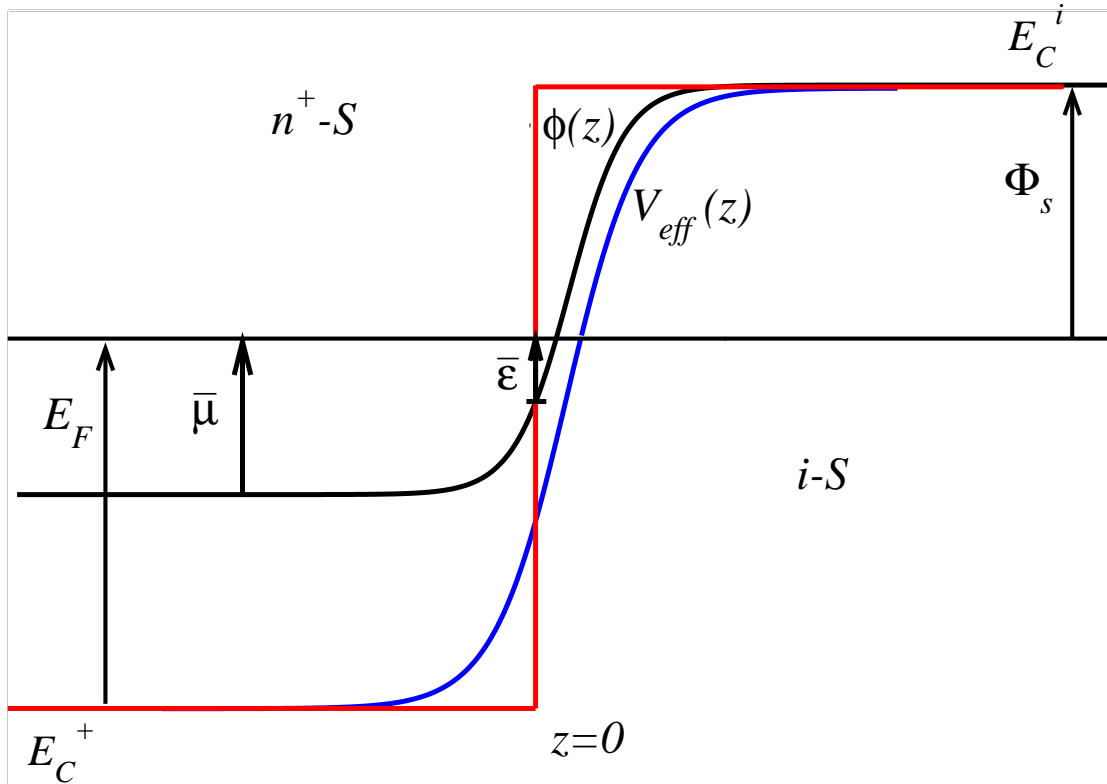


FIG. 2: Band diagram of $n^+ = i$ junction and schematic behavior of $\phi(z)$ and $V_e(z)$

i -semiconductors respectively, $V_e(z)$ is the exact one-electron quasi-particle potential, and $\phi(z)$ is the exact electrostatic (Hartree) energy of the electron related to the electron density $n(z)$ through the Poisson's equation:

$$\frac{d^2}{dz^2} = \frac{4 N e^2}{\epsilon} \quad \phi(z) = \frac{n}{N} ; \quad (2)$$

where $\theta(y)$ is a step function. The quantities μ and ϵ are the exact chemical potential many-body effects included [20] and the exact total energy per one electron in the bulk respectively. All these quantities are well known within the local density approximation (LDA). In particular,

$$\mu = \frac{3}{5}E_F + \frac{3}{4}E_{ex} + E_c = \frac{2.21}{r_s^2} - \frac{0.916}{r_s} - \frac{0.88}{r_s + 7.8} \text{ Ry}; \quad (3)$$

where we introduced the effective Rydberg:

$$\text{Ry} = \frac{e^2}{2\epsilon a_0} = \frac{\tilde{\epsilon}^2}{2m^* a_0^2}; \quad (4)$$

ϵ is the dielectric constant, m^* is the effective mass, and a_0 is the effective Bohr radius:

$$a_0 = \frac{\epsilon \tilde{\epsilon}^2}{m^* e^2}; \quad (5)$$

The parameter r_s is related to the bulk electron concentration n_0 in the n^+ region as follows:

$$r_s = \frac{3}{4 n_0 a_0^3}^{1/3} = \frac{3}{4 N a_0^3}^{1/3}; \quad (6)$$

where N is the donor concentration and we assume that all the donors are ionized, i.e. $n_0 = N$.

Since μ is known the problem of finding the barrier ϕ_s is reduced to calculation of the potential difference $\phi(1) - \phi(0)$ caused by the interfacial dipole layer. The latter can be expressed as:

$$\phi(1) - \phi(0) = \frac{4\pi e^2 Q}{\epsilon k_F} \frac{\int_0^{R_1} g(\eta) d\eta}{\int_0^{R_1} g(\eta) d\eta} \frac{\int_0^{R_1} j(\eta)^2 d\eta}{\int_0^{R_1} j(\eta)^2 d\eta}; \quad (7)$$

where we introduced dimensionless energy $\eta = [E - V(\eta)] - E_F$, and coordinate $\eta = k_F z - (3/2N)^{1/3} z$. Here Q is the total number of electrons per unit area in the half-space $z < 0$, and

$$g(\eta) = \frac{3}{4} \frac{1}{\eta} \quad (8)$$

is a dimensionless effective density of the occupied states for electrons moving perpendicular to the interface.

Eq. (7) is exact and follows from the properties of the 1-dimensional Poisson's equation. The internal workfunction ϕ_s can be calculated exactly provided that we know the eigenfunctions of the Kohn-Sham equations $\psi(z)$:

$$\frac{\tilde{\epsilon}^2}{2m^*} \frac{d^2}{dz^2} \psi(z) + V_e(z) \psi(z) = E \psi(z) \quad (9)$$

with

$$V_e(z) = \chi(z) + E_{ex}(n(z)) + E_c^0(n(z)) - \frac{1.22}{r_z} Ry - 0.88 \frac{7.8 + 4r_z}{(7.8 + r_z)^2} Ry; \quad (10)$$

where $r_z = (4 - n(z)a_0^3)^{1/3}$, electrostatic energy $\chi(z)$ is related to $n(z)$ via Eq. (2), and

$$n(z) = N \int_0^{z+1} g(\eta) j^2(\eta) d\eta; \quad (11)$$

The detailed numerical solution of Eqs. (9)–(11) will be published elsewhere. Here we will estimate the interface dipole term using approximate eigenfunctions of the one-electron Schrodinger equation with the potential in the form of a rectangular step of the height $E_F + \chi_s$ (shown in red in Fig. 2):

$$j(\eta) = \frac{2}{1 + \eta_0} \exp\left[-\frac{\eta}{2} \sqrt{1 + \eta_0^2}\right]; \quad (12)$$

where $\eta_0 = \chi_s/E_F$. The wavefunctions in Eq. (12) capture the most important feature of the exact solution – exponential asymptotic decay far from the interface [23]. An estimate for the value of the parameter Q can be obtained from the Thomas-Fermi equation inside n^+ -region ($z < 0$). This yields:

$$Q = 0.88 r_s^{5/2} a_0^2; \quad (13)$$

Substituting Eqs. (12) and (13) in Eq. (7) we obtain:

$$\chi_s - \frac{3.68}{r_s^2} \eta_0 = \frac{0.982}{r_s^{3/2}} f(\eta_0) - \frac{2.21}{r_s^2} + \frac{0.916}{r_s} + \frac{0.88}{r_s + 7.8}; \quad (14)$$

where

$$f(y) = \frac{1 + 3y}{2} \frac{\sqrt{1 + 3y} \coth \sqrt{1 + y} - \coth^2 \sqrt{1 + y}}{y(1 + 3y) + (1 + y)(1 - 3y) \cot^2 \sqrt{y}}; \quad (15)$$

The results of the application of Eq. (14) are shown in Fig. 3 and compared with the exact numerical results by Lang and Kohn [20]. We see that our estimate is in good agreement with the exact theory for $r_s \leq 2.5$. As we will see below this region of electron densities is the most relevant one for quantum computing purposes in n^+ -Si system.

In order to apply our results to Si we have to take into account multi-valley character of the kinetic energy operator. If we neglect the effective mass anisotropy the main effect will consist in replacing parameter k_F with its renormalized value $(3^{-2}N = g_v)^{1/3}$, where g_v is the number of valleys in the conduction band. The analog of Eq. (14) reads:

$$\chi_s - \frac{3.68}{g_v^{2/3} r_s^2} \eta_0 = \frac{0.982}{r_s^{3/2}} f(\eta_0) - \frac{2.21}{g_v^{2/3} r_s^2} + \frac{0.916}{g_v^{1/3} r_s}; \quad (16)$$

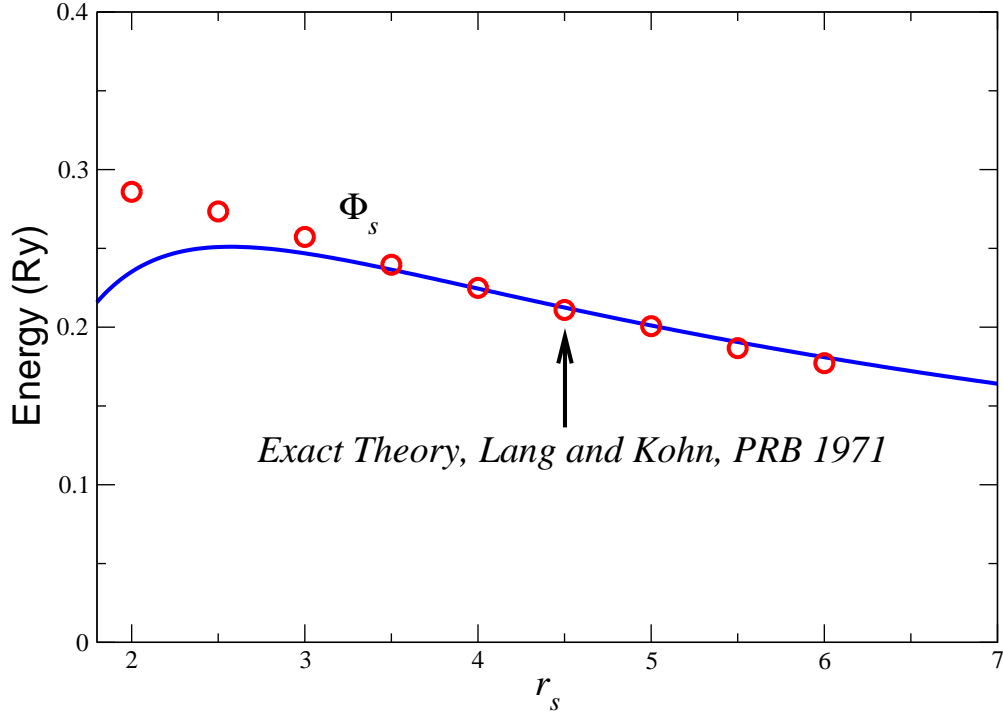


FIG. 3: Workfunction of a jellium metal at different densities: blue curve – Eq. (14), circles – exact theory [20]

where the number of valleys $g_v = 6$ for Si. Here we have omitted insignificant correlation energy. The results of the calculations of Φ_s by means of Eq. (16) are shown in Fig. 4. We used $Ry = 34.5 \text{ meV}$, and $a_0 = 18.3 \text{ \AA}$ [24]. It can be seen from Fig. 4 that for the purposes of quantum computing on long-lived donor states of Li in Si [12] the electron concentration in n^+ electrodes must be in the range between $2.55 \cdot 10^{18} \text{ cm}^{-3}$ ($g_v^{1=3} r_s = 4.5$) and $1.5 \cdot 10^{18} \text{ cm}^{-3}$ ($g_v^{1=3} r_s = 2.5$). The lower limit is the metal-insulator transition threshold for n^+ Si [24, 25] while the upper limit corresponds to the point where the total conduction band offset $\phi_0 = E_F + \Phi_s$ between n^+ - and i -layers reaches 1 Ry . A schematic energy diagram corresponding to this range of concentrations is shown in Fig. 5 (a). It can be seen that the first two lowest energy levels of Li donor in Si are separated by an energy gap from a continuum of the many-body states in the n^+ -electrodes. Thus our qubit is protected from a dephasing caused by dynamic fluctuations of the electron density in the contacts.

Qubit state readout via photo-assisted resonant tunnelling. The $n^+ - i - n^+$ or $p^+ - i - p^+$ structures can be used for readout the electron states in systems considered in Refs. [11, 12]. Indeed, and individual qubit in these systems is encoded on the ground and long-lived first

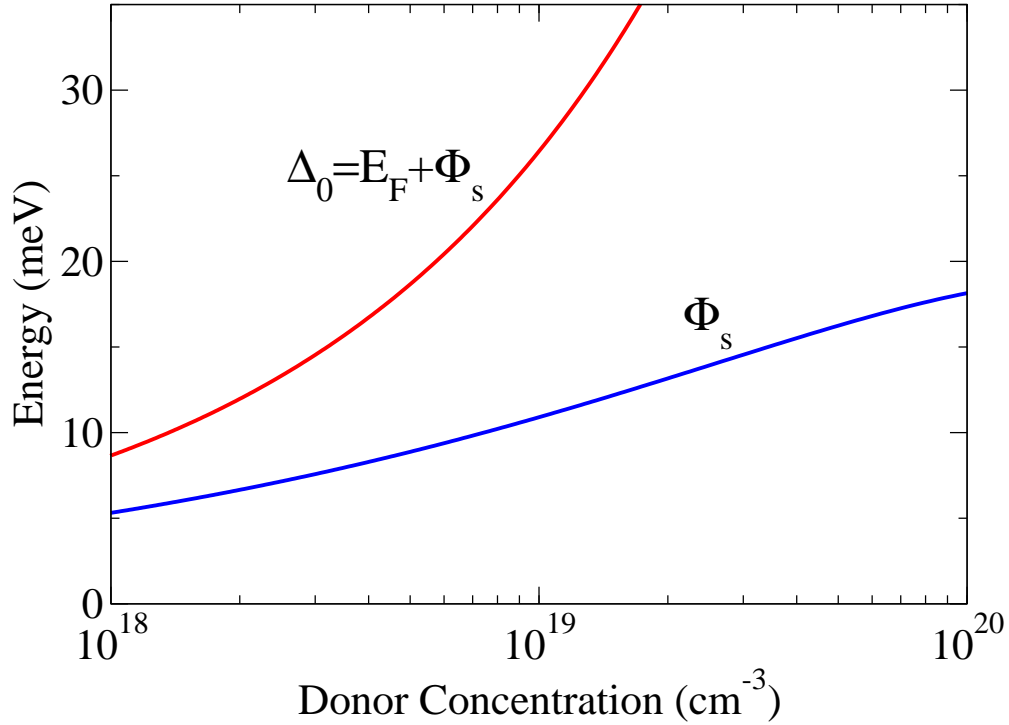


FIG. 4: Barrier Φ_s of $\text{Si}^+\text{n-i}$ junctions at different donor concentrations (blue), Eq. 16, the total conduction band offset $\Delta_0 = E_F + \Phi_s$ is also shown in red.

excited state of a shallow donor or acceptor. According to estimates of Ref. [12] for one of those systems, Li donor in Si, the lifetime of the first excited state $1s, B_2$ (further denoted as $|j\rangle$) can be up to 1 second if the energy separation between this state and the ground state $1s, A_1$ (further denoted as $|i\rangle$) is ~ 0.06 meV. The ionization energy of the ground state of Li in Si, $I_0 = 1$ Ry = 34.5 meV. The excited $2p_0$ -state has the ionization energy $I_p = 11.5$ meV and the lifetime $\tau_p \sim 10^8$ s [26]. The readout can be realized when the lower levels $|i\rangle$ and $|j\rangle$ lie below E_c^+ and the $2p_0$ -level is higher than E_c^+ (Fig. 5 (b)). This situation corresponds to doping concentration $N \sim 10^{19} \text{ cm}^{-3}$. In this case the lower levels of the qubit lie below the continuum spectrum of the contacts in equilibrium and one of them is populated by the electron which does not interact with electrons in conducting n^+ layers (Fig. 5 (b)). When bias voltage $V \sim 30$ meV is applied the $2p_0$ -level moves down below the Fermi level of the left electrode and all Li levels are shifted under the action of electric field $E = V/d \sim 4 \text{ KV/cm}$ (Fig. 5 (c)). Radiation absorption between lower Li states $|i\rangle$ or $|j\rangle$ and the state $2p_0$ depends on the polarization of the infrared light. Thus, selecting the radiation by frequency and polarization we can excite only the state $|i\rangle$ or $|j\rangle$ depending

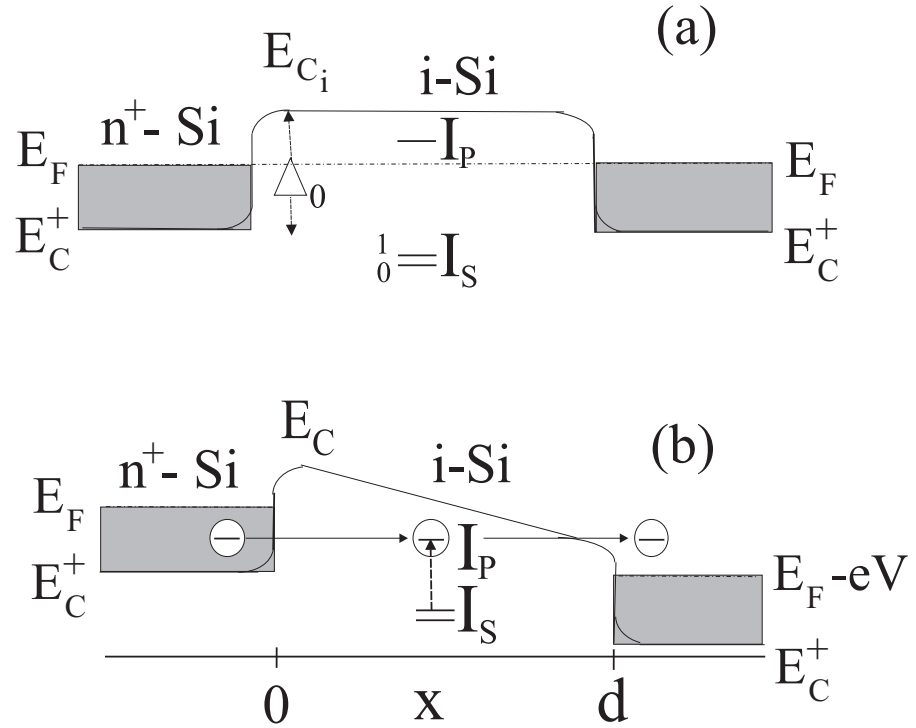


FIG. 5: Schematic band diagrams of n^+ - i structure in equilibrium (a) and at a bias voltage V (b).

on the polarization and detect the tunnelling current through the $2p_0$ -level of the ionized impurity (Fig. 5(c)). The tunnelling frequency can be estimated as

$$\Gamma = (E_F - \epsilon) \exp(-2d/l_0);$$

where $l_0 = (\hbar^2/2m_s)^{1/2}$ is the tunnelling length. For typical values $\epsilon_s = 8 \text{ meV}$, $E_F - \epsilon = 20 \text{ meV}$ and $d = 25 \text{ nm}$ we obtain $\Gamma > 10^{10} \text{ Hz}$, i.e. $\Gamma \gg \Gamma_p$. It means that many electrons will tunnel through the excited $2p_0$ -level before the recombination process occurs, the donor becomes neutral, and the current terminates. Thus a single-qubit measurement with the current signal much stronger than that of the single-electron measurement can be realized. The tunnelling current depends dramatically on Li position, namely it has a sharp maximum when the Li atom is placed equidistantly between the electrodes [27, 28]. This effect can be used for in situ placement control of Li atoms during the growth process at high temperatures, when the highly-mobile Li ions are guided to their permanent final positions by an external electric field.

The effect of photo-stimulated resonant tunnelling can be verified independently in the experiments on n -doped Li layers placed between two n^+ -electrodes. These structures are

similar to those studied in Ref. [29]. Consider kinetics of the resonant current immediately after the photoionization occurs. For simplicity we assume that the tunnelling frequency is relatively small, $\Gamma \ll W_{\text{dec}} \ll 1$, where $W_{\text{dec}} \ll 1$ is a total decoherence width of the $2p_0$ level. Then the rate equations for sequential resonant tunnelling read:

$$\frac{dn_1}{dt} = \Gamma_1(1 - n) - \Gamma_r n_1 - W n_1(1 - n_0) \quad (17)$$

$$\frac{dn_0}{dt} = W n_1(1 - n_0) \quad (18)$$

Here n_i are the populations of the levels 0 and 1, $n = n_1 + n_0$, Γ_1 and Γ_r are inverse elastic tunnelling lifetimes, and W is the inverse recombination time. The first term in Eq. (17) takes into account the Coulomb blockade effect. The difference between Eqs. (17), (18) and conventional equations [30] is that the resonant current is decaying via the recombination channel. If $\Gamma_1(x) \ll W$ the population n_1 quickly attains quasi-equilibrium and the tunnelling current can be expressed as:

$$I = \Gamma_1(1 - n) = \frac{\Gamma_1 \Gamma_r}{\Gamma_1 + \Gamma_r} \frac{1}{1 + \tau}; \quad (19)$$

where

$$\tau = \frac{1}{\Gamma_1 + \Gamma_r} \quad (20)$$

Therefore, the photo-stimulated resonant tunnelling current through the n -doped Li layer will be characterized by a long-term decay kinetics $I \propto 1/\tau$. We note that the condition for the sequential tunnelling considered above is opposite to that required for the qubit readout. In the latter case $\Gamma \approx W_{\text{dec}} \ll 1$ and a coherent resonant tunnelling regime needs to be considered.

Conclusion We proposed a device based on $n^+ - i - n$ heterostructures for electronic control and readout of qubit encoded in two lowest states of a shallow donor of Li in Si. Qubit state readout is based on the polarization-sensitive photo-stimulated resonant tunnelling effect. A key feature of the system is that the qubit states (first two lowest energy levels of a donor) are separated by a finite energy gap from a continuum of the many-body states of the controlling electrodes. Therefore the qubit is protected from a dephasing caused by dynamic fluctuations of the electron density in the contacts. It is of interest to apply the proposed scheme for the case of qubits based on orbital states of quantum dots as well as on shallow acceptor states [11] (in the latter case $p^+ - i - p^+$ structures should be used).

APPENDIX A : THOMAS-FERM I EQUATION

According to the Thomas-Fermi theory the electrons are considered as classical particles obeying Fermi statistics. Then the maximal energy of an electron near point z reads:

$$E_{\text{max}} = \frac{p_{\text{max}}^2}{2m} + \phi(z); \quad (\text{A } 1)$$

where $\phi(z) = -e' \psi(z)$ is the electrostatic (Hartree) energy of an electron in the field of all other electrons and external potential, $e > 0$ is the magnitude of the elementary charge, ψ is the electrostatic potential, and p_{max} is the maximal momentum of the electron. The maximal energy of the electron is nothing but a chemical potential at $T = 0$. This chemical potential must be constant in equilibrium:

$$E_{\text{max}} = \text{const} = E_F; \quad (\text{A } 2)$$

where

$$E_F = \frac{\hbar^2}{2m} (3\pi^2 n_0)^{2/3} = \frac{\hbar^2}{2m} (3\pi^2 N)^{2/3} = \frac{\hbar^2 k_F^2}{2m}; \quad (\text{A } 3)$$

Here $n_0 = N$ is the electron density in the bulk and N is the concentration of donors. The maximal (Fermi) momentum can be related to the number density of the electrons $n(z)$:

$$p_{\text{max}} = \hbar k_F [n(z)] = \hbar (3\pi^2 n(z))^{1/3} \quad (\text{A } 4)$$

Thus, from Eqs. (A 1)–(A 4) the relation between electron density $n(z)$ and electrostatic energy $\phi(z)$ within the Thomas-Fermi model is:

$$n = N \left(1 - \frac{\phi(z)}{E_F} \right)^{3/2} \quad (\text{A } 5)$$

The Poisson equation for ϕ reads:

$$\frac{d^2 \phi}{dz^2} = \frac{4\pi N e^2}{\epsilon} \left(1 - \frac{\phi(z)}{E_F} \right)^{3/2}; \quad (\text{A } 6)$$

Introducing dimensionless energy $u = 1 - \phi/E_F$, from Eqs (A 5)–(A 6) we obtain the self-consistent, dimensionless, Thomas-Fermi equation:

$$\frac{d^2 u}{dz^2} = \frac{2}{3} u^{3/2} \quad (\text{A } 7)$$

Here we introduced dimensionless length $\xi = z/L_{\text{TF}}$, where L_{TF} is the Thomas-Fermi screening length:

$$L_{\text{TF}} = \frac{\epsilon}{4\pi N e^2} \left(\frac{E_F}{\hbar^2} \right)^{1/2} = \frac{1}{3} k_F a_0^2 r_s^{3/2} = \frac{a_0}{2} \frac{1}{3} \frac{1}{(N a_0^3)^{1/6}} \quad (\text{A } 8)$$

Here $a_0 = \frac{\hbar^2}{m e^2}$ is the Bohr radius.

The equation $u'' = f(u)$ can be solved as:

$$\frac{du}{dz} = \sqrt{2 \int f(u) du + C_{\text{const}}} \quad (\text{A } 9)$$

Therefore, we obtain:

$$\frac{du}{dz} = \frac{8}{15} u^{5/2} - \frac{4}{3} (1 - u) \quad (\text{A } 10)$$

It can be shown ([22]) that $u(0) = 3/5$. Therefore the solution of the Thomas-Fermi equation for $z > 0$ reads:

$$u = \frac{3}{5} \frac{1}{(1 + \frac{z}{L_{TF}})^4}; \quad (\text{A } 11)$$

where $L_{TF} = (10 \frac{\hbar^2}{15})^{1/2}$. Finally, from Eqs. (A 5) and (A 11) we obtain for $z > 0$:

$$\frac{n}{N} = \frac{3}{5} \frac{1}{1 + \frac{z}{L_{TF}}} \quad (\text{A } 12)$$

Integrating Eq. (A 12) from 0 to L_{TF} we obtain the total number of electrons per unit area in the upper half-space (or holes in the lower half-space):

$$Q = \frac{p}{2} \frac{3}{5} L_{TF} N = \frac{0.088}{r_s^{5/2} a_0^2} \quad (\text{A } 13)$$

and the prefactor in the expression for $n(z)$ (0):

$$\frac{4 e^2 Q}{\epsilon k_F} = \frac{p}{2} \frac{3}{5} r_s^{3/2} R_y \quad (\text{A } 14)$$

For a multi-valley semiconductor with isotropic spherical valleys we have to replace Eq. (A 4) with

$$p_{\text{max}} = \frac{1}{k_F} [n(z) g_v] = \frac{1}{3} \frac{1}{k_F} [n(z) g_v]^{1/3}; \quad (\text{A } 15)$$

where g_v is the number of valleys. Therefore, the screening length and Q will change accordingly, however Eq. (A 14) will not.

APPENDIX B: ELECTRON DENSITY

To calculate the electron density $n(z)$ using LDA wavefunctions we have to take into account the fact that we are dealing with the wavefunction of a 3D semi-infinite metal:

$$\psi(\mathbf{r}) = \frac{1}{V} e^{i \mathbf{k} \cdot \mathbf{r}} \psi_{k_z}(z) \quad (\text{B } 1)$$

The quantum number k_z describes the bulk states, i.e. $\psi_{k_z}(z) = A_{k_z}(z) + A_{k_z} \sin(k_z z + \phi)$ as $z \rightarrow -\infty$. Using Eq. (B1) we can calculate the number density:

$$n(z) = \frac{2}{V} \frac{V}{(2\pi)^3} \int_{k_F}^{\infty} dk_z \int_0^{k_F} 2k_k dk_k (k_F^2 - k_k^2 - k_z^2) \psi_{k_z}(z)^2 \quad (\text{B2})$$

$$= \frac{1}{2\pi^2} \int_0^{k_F} (k_F^2 - k_z^2) \psi_{k_z}(z)^2 dk_z \quad (\text{B3})$$

Introducing dimensionless energy $\epsilon = \hbar^2 k_z^2 / (2m E_F)$ we further obtain:

$$n(z) = \frac{1}{4\pi^2} \frac{2m E_F}{\hbar^2} \int_0^{\infty} \frac{1}{\epsilon} \psi_{\epsilon}(z)^2 d\epsilon = \frac{3}{4} N \int_0^{\infty} \frac{1}{\epsilon} \psi_{\epsilon}(z)^2 d\epsilon \quad (\text{B4})$$

If we know Q we can normalize the wavefunctions $\psi_{\epsilon}(z)$ in the upper half-space:

$$\psi_{\epsilon}(z)^2 = \frac{Q \int_0^{\infty} \psi_{\epsilon}(z)^2 dz}{N \int_0^{\infty} d\epsilon \int_0^{\infty} \psi_{\epsilon}(z)^2 dz} \quad (\text{B5})$$

where

$$g(\epsilon) = \frac{3(1 - \epsilon)}{4\pi^2} \quad (\text{B6})$$

APPENDIX C: 1D POISSON EQUATION

The general solution of 1D Poisson equation (A6) reads:

$$\psi(z) = \frac{4}{\epsilon} \frac{e^{2\epsilon z}}{\epsilon} \int_0^{\infty} (z^0 - z) \psi^0(z^0) dz^0; \quad (\text{C1})$$

where $\psi(z) = n(z) - N$ ($\psi(z) = 0$). If the system is electrically neutral, then

$$\int_0^{\infty} \psi(z) dz = 0 \Rightarrow \int_0^{\infty} \frac{4}{\epsilon} \frac{e^{2\epsilon z}}{\epsilon} \int_0^{\infty} (z^0 - z) \psi^0(z^0) dz^0 dz = 0; \quad (\text{C2})$$

and

$$\int_0^{\infty} \psi(z) dz = 0 \Rightarrow \int_0^{\infty} \frac{4}{\epsilon} \frac{e^{2\epsilon z}}{\epsilon} \int_0^{\infty} (z^0 - z) \psi^0(z^0) dz^0 dz = 0; \quad (\text{C3})$$

Substituting Eqs. (B4) and (B5) in Eq. (C3) we obtain Eq. (7) of the paper.

APPENDIX D: MODIFIED BARDEEN TREATMENT.

J. Bardeen, in his pioneering work of 1936 [18], calculated a moment of a surface dipole layer using a model step-like potential barrier of infinite height. Here we will follow a similar

path but assume that the height of the barrier is finite. The value of the barrier will be determined self-consistently.

Let us approximate the exact self-consistent potential of a semi-infinite jellium metal with a step function:

$$V_{\text{eff}}(z) = V(-1) + (E_F + \phi_s) [L(0) - z]; \quad (D 1)$$

Here, as previously, $\phi_s = E_F$, and we assumed that the region of the classical motion of electrons is extended beyond the metal surface $z = 0$. This assumption is necessary to ensure electroneutrality of the system. Integrating the charge densities inside and outside the metal and imposing the electroneutrality condition we find $L(0)$:

$$L(0) = \frac{q_1(0) - q_2(0)}{k_F}; \quad (D 2)$$

where

$$q_1(0) = \frac{3}{8} - \frac{3}{16} \frac{\sqrt{1+3\phi_0}}{1+\phi_0} + (3-\phi_0) \coth^{-1} \left(\frac{\sqrt{1+3\phi_0}}{1+\phi_0} \right) \quad (D 3)$$

$$q_2(0) = \frac{3}{16} \frac{\sqrt{1+3\phi_0}}{1+\phi_0} + (1-\phi_0) \coth^{-1} \left(\frac{\sqrt{1+3\phi_0}}{1+\phi_0} \right) \quad (D 4)$$

$$(D 5)$$

The limiting value $L(1) = 3/8k_F$ was previously found by Bardeen [18] (see also Ref. [31]).

As a next step we integrate the Poisson's equation and employ Eq. (1) to determine ϕ_0 self-consistently. This leads to a transcendental equation similar to Eq. (14):

$$\phi_s - \frac{3.68}{r_s^2} \phi_0 = \frac{1.627}{r_s} f(\phi_0) - \frac{2.21}{r_s^2} + \frac{0.916}{r_s} + \frac{0.88}{r_s + 7.8}; \quad (D 6)$$

where

$$f(\phi_0) = \phi_0(0) + \frac{1}{2} [q_1^2(0) - q_2^2(0)]; \quad (D 7)$$

and

$$\phi_0(0) = \frac{1+3\phi_0 - 3\phi_0 \frac{\sqrt{1+3\phi_0}}{1+\phi_0} \coth^{-1} \left(\frac{\sqrt{1+3\phi_0}}{1+\phi_0} \right)}{4(1+\phi_0)} \quad (D 8)$$

The value of ϕ_s obtained from Eq. (D 6) is shown in Fig. 6 and compared with our previous Thomas-Fermi result. We see that the Thomas-Fermi result is in better agreement with the numerical calculations [20]. We believe that this is due to the fact that the total charge

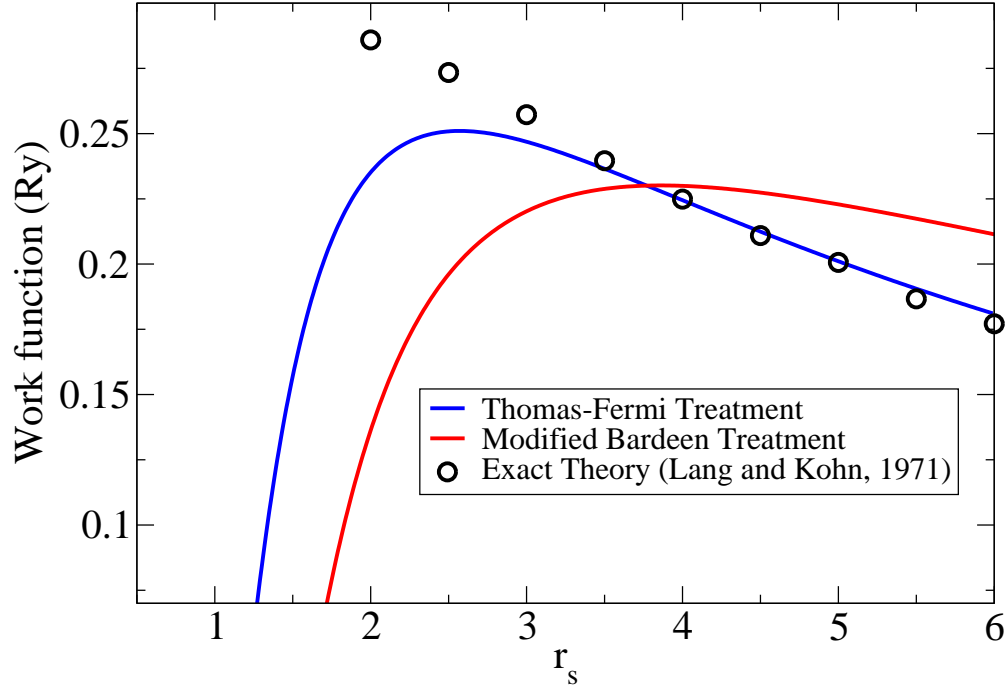


FIG. 6: Workfunction of a jellium metal at different densities: blue curve – Eq. (44), red curve – Eq. (46), circles – exact theory [20]

within the metal is better reproduced by a self-consistent (but not oscillatory) Thomas-Fermi density rather than by an oscillatory (but not fully self-consistent) density obtained from the modified Bardeen treatment.

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